

March 20, 2008

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Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450 Art Unit 2851

Attn: Mail Stop AF

Re: U.S. Utility Patent Application

Application No. 10/811,070; Filed: March 29, 2004

For: Lithographic Apparatus and Device Manufacturing Method

Inventors: Van Der Feltz et al. Our Ref: 1857.2780000

Sir

Transmitted herewith for appropriate action is the following document:

Amendment and Reply Under 37 C.F.R. § 1.116.

The above-listed document is being filed electronically through EFS-Web.

In the event that extensions of time are necessary to prevent abandonment of this patent application, then such extensions of time are hereby petitioned.

Fee payment is provided through online credit card payment. The U.S. Patent and Trademark Office is hereby authorized to charge any fee deficiency, or credit any overpayment, to our Deposit Account No. 19-0036.

Respectfully submitted,

STERNE KESSLER, GOLDSTEIN & FOX P.L.L.C.

Jason D. Eisenberg Attorney for Applicants Registration No. 43,447

JDE/lvt Enclosure(s) 797533_1 DOC